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MEMC TP-01-2450 (3009)
PATENT

IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Robert J. Falster, et al. Art Unit: 1765
Serial No.: 10/615,127
Filed: July 8, 2003
Confirmation No.: 8157
For: PROCESS FOR PREPARING A STABILIZED IDEAL
OXYGEN PRECIPITATING SILICON WAFER
Examiner: Felisa C. Hiteshew

May 10, 2005

AMENDMENT B

TO THE COMMISSIONER FOR PATENTS,

SIR/MADAM:

Please enter the following amendments.

Amendments to the Claims are reflected in the listing of
claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.

Conclusion begins on page 9 of this paper.